10/644, 757 SHEET 1 OF 1

LIST	OF PRIOR	ART CIT	ED BY	ATTY. DOCKET NO. RPL-0010 REI		REISSUE APPLN. OF PATENT NO. 6,276,980B1	
APPLICANT (PTO-1449)				APPLICANT(S) Sang-Tae KIM			
						GROUP 2879	
U.S. PATEN	T DOCUMENTS						
EXAMINER'S INITIALS	*PATENT NO.	*ISSUE DATE	, *INVENTOR NAME		CLASS	SUBCLASS	FILING DATE
AW	3,774,038	11/1973	Ligtenberg			_	
AN	4,243,455	1/1981	Shiba et al.				
AW.	4,507,151	3/1985	Simm et al.		-		•
WYV	5,122,215	6/1992	Shibata et al.				
AW.	5,662,846	9/1997	Swarts				
W	5,998,920	12/1999	Kim		_		
XVV	6,120,975	9/2000	Tokai et al.		_		
- U*-							
					· ·		
	<del> </del>					<b> </b>	
	<del> </del>		<del> </del>	<del></del>	1.		
	_L	U.S. PATE	NT APPLICAT	ION PUBLICATIO	NS.	<del></del>	
,	*PATENT APPLN. PUB. NO.	PUB. DATE	*APPLICANT		CLASS	SUBCLASS	
	<del></del>	· <del>[</del>		<del></del>	<del> </del>		
	<del>-1</del>	<u>.l</u>	U.S. PATENT APP	PLICATIONS	1		<u>.</u>
	*APPLN.	*FILING			T		
	NO.	DATE	INVENTOR		CLASS	SUBCLASS	
	<b></b>	ļ	ļ				
	<u> </u>	<u></u>			<u></u>		
73443415ED1		F	OREIGN PATENT	DOCUMENTS	<del></del>	<del>                                     </del>	Translation
EXAMINER' S INITIALS	PATENT NO.	DATE		DUNTRY	CLASS	SUBCLASS	Yes No
			1				
					1		
OTHER	ART (Including	Author, Title,	Date, Pertine	nt Pages, Publish	er, Place	of Publicatio	n. Etc.)
	T /			.:	<del></del>		
-							
	1/		· · · · · · · · · · · · · · · · · · ·	······································			
	<del>/</del>				- ··· -··-		
		<del></del>		<del></del>		<del></del>	
		<del></del>					
EYAMINER		<del></del>		DATE CONSIDERE	<u>.</u>	<del></del> -	
CXXIVIIIAEIX	lozach Ut Pliam	2			3/27	Hao	

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.